



2812  
Attorney Docket No.: SEL 139 DIV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Shunpei Yamazaki et al. )  
Serial No.: 09/808,162 , )  
Filed: March 13, 2001 )  
For: Method For Fabricating A )  
Semiconductor Device )  
Examiner: V. Simkovic )  
Art Unit: 2812 )

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June 30, 2003

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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace

Signature

6/30/2003

Date

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT B

In response to the Office Action of March 28, 2003, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend the claims as follows:

13 (Amended). A method according to claim 1 further comprising the step of:

carrying out a second heat treatment at a temperature of not lower than 900°C.

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